



**PATENT APPLICATION**

RCE/2817  
IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi YAMASAKI et al.

Group Art Unit: 2811

Application No.: 09/970,766

Examiner: S. Hu

Filed: October 5, 2001

Docket No.: 110791

For: METHOD OF MANUFACTURING  
SEMICONDUCTOR SUBSTRATE,  
SEMICONDUCTOR SUBSTRATE, ELECTRO-  
OPTICAL APPARATUS AND ELECTRONIC  
EQUIPMENT

**MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

☒ Applicants further request entry and consideration of the Amendment After Final Rejection filed July 21, 2004.

☒ Applicants also further request entry and consideration of the attached Supplemental Amendment.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 157554 in the amount of ☒ \$770.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

*Leana Levin*

James A. Oliff  
Registration No. 27,075

Leana Levin  
Registration No. 51,939

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770.00 DP

JAO:LL/lxl

Date: August 23, 2004

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461